

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Addiese: COMMISSIONER FOR PATENTS FO Box 1450 Alexandra, Virginia 22313-1450 www.webje.gov

APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/518,119	04/10/2006	Catherine Chaix	0510-1231	3267
466 7590 04082010 YOUNG & THOMPSON 209 Madison Street			EXAMINER	
			FORD, NATHAN K	
Suite 500 Alexandria, V.	A 22314		ART UNIT	PAPER NUMBER
Thomas A. T. 2007		1712		
			NOTIFICATION DATE	DELIVERY MODE
			04/08/2010	EL ECTRONIC

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

Notice of the Office communication was sent electronically on above-indicated "Notification Date" to the following e-mail address(es):

DocketingDept@young-thompson.com

Application No. Applicant(s) 10/518,119 CHAIX ET AL. Office Action Summary Examiner Art Unit NATHAN K. FORD 1712 -- The MAILING DATE of this communication appears on the cover sheet with the correspondence address --Period for Reply A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) OR THIRTY (30) DAYS. WHICHEVER IS LONGER, FROM THE MAILING DATE OF THIS COMMUNICATION. Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication. If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication - Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b). Status 1) Responsive to communication(s) filed on 22 December 2009. 2a) This action is FINAL. 2b) This action is non-final. 3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under Ex parte Quayle, 1935 C.D. 11, 453 O.G. 213. Disposition of Claims 4) Claim(s) 1-13 is/are pending in the application. 4a) Of the above claim(s) _____ is/are withdrawn from consideration. 5) Claim(s) _____ is/are allowed. 6) Claim(s) 1-13 is/are rejected. 7) Claim(s) _____ is/are objected to. 8) Claim(s) _____ are subject to restriction and/or election requirement. Application Papers 9) The specification is objected to by the Examiner. 10) ☐ The drawing(s) filed on 15 December 2004 is/are: a) ☐ accepted or b) ☐ objected to by the Examiner. Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a). Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d). 11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152. Priority under 35 U.S.C. § 119 12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some * c) None of: Certified copies of the priority documents have been received. 2. Certified copies of the priority documents have been received in Application No. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received.

1) Notice of References Cited (PTO-892)

Paper No(s)/Mail Date

Notice of Draftsperson's Patent Drawing Review (PTO-948)

3) Information Disclosure Statement(s) (PTO/SB/08)

Attachment(s)

Interview Summary (PTO-413)
Paper No(s)/Mail Date.

6) Other:

5) Notice of Informal Patent Application

Application/Control Number: 10/518,119 Page 2

Art Unit: 1712

DET DETAILED ACTION

Applicant's Response

Acknowledged is the applicant's response filed December 22, 2009. All pending claims have been amended.

The applicant contends:

(1) The cited prior art does not teach "recesses" formed in a wall and centered on the main axis of the material

sources.

(2) None of the cited references articulate any features which can be individually controlled to plug or clear said

recesses. Nakamura merely discloses a single gate valve, and Tomofuji is completely silent regarding the matter.

In response, these arguments have been considered but are not persuasive for reasons elaborated below:

(1) As described in the pre-grant publication of the applicant's specification, recess simply refers to an opening in a

wall [0040]. Clearly, with reference to Figure 1, Nakamura teaches a wall (21) having a central opening, or recess,

formed therein. Although Nakamura does not form a plurality of recesses in a single wall, Tomofuji demonstrates the

art-recognized suitability of this configuration - Figure 1 delineates a single wall comprising three recesses centered

on the main axis of each corresponding material source. It is the examiner's position that if provided with the

teaching of Tomofuji, the skilled artisan would have been readily capable of reconstituting Nakamura's partition wall

such that each material source is provided with an exclusive recess through which to supply material.

(2) Nakamura fully anticipates the feature of plugging a recess - valve 22 is used for precisely this purpose (6, 17-

22). Following the reconstitution of the partition wall to include multiple recesses, it would have been further

obvious to outfit each recess with a gate valve to shut off material flow as desired. It should also be noted that each

valve can be individually controlled by hand, whereby it has been held that broadly providing a mechanical or

automatic means to replace manual activity which has accomplished the same result involves only routine skill in the

art (In re Venner, 120 USPQ 192).

Claim Interpretation

By employing means for language, the applicant invokes USC 112, 6th paragraph.

Claim 1: The "means for plugging or clearing each of said recesses" will be interpreted as being inclusive of at

least a mask according to paragraph forty of the applicant's specification.

Art Unit: 1712

Claim 9: The "means for controlling the pressure in order to measure independently the pressure in the first volume and the second volume" will be interpreted as being inclusive of at least a pressure gauge connected to an external pressure control device according to paragraph thirty-six of the applicant's specification.

Claim Objections

Claims 1-13 are objected to because of the following informalities: The second paragraph of claim 1 reads, "a wall providing...tightness and delinating [sic] within the vacuum chamber." The examiner understands the proper term to be delineating. Appropriate correction is required.

Claim Rejections - 35 USC § 112

The following is a quotation of the second paragraph of 35 U.S.C. 112:

The specification shall conclude with one or more claims particularly pointing out and distinctly claiming the subject matter which the applicant regards as his invention.

Claim 3 is rejected under 35 U.S.C. 112, second paragraph, as being indefinite for failing to particularly point out and distinctly claim the subject matter which applicant regards as the invention. The claim recites, "An evaporation chamber...wherein when growing..." It is not clear from the claims what is being grown.

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 1-4, 8, 11, and 13 are rejected under 35 U.S.C. 103(a) as being unpatentable over Nakamura et al., US 5,423,914, in view of Tomofuii, US 6,142,097.

Claims 1-3: Nakamura discloses an evaporation device comprising (Fig. 2):

- A vacuum chamber (2) (5, 22-25);
- A wall (21) which divides the chamber into a first (upper) and second (lower) volume (5, 62ff);
- · A first pumping unit (20) to pump the first volume (6, 25-30);
- A second pumping unit (1) to pump the second volume (6, 30-33);
- Sources of material (7) placed in the first volume (5, 54-55);

Application/Control Number: 10/518,119

Art Unit: 1712

Sources of material (31, 32) placed in the second volume;

A recess formed in the wall which is centered on the main axis of the sources of material (6, 16-22);

Masks (9, 22) for covering the recess (7, 5-8);

Wherein each mask is individually controlled.

Nakamura teaches only a single recess formed in the wall, whereas the claim is being interpreted to require at least two recesses. Nevertheless, it would necessitate only a most nominal revision to form two recesses in Nakamura's division wall. Tomofuji, for instance, delineates a dividing wall (4) manifesting three recesses (5a-c) which correspond to individual material sources (10a-c). The recesses enhance control of the vapor stream directed toward the substrates (5, 20-30). Provided with this structural paradigm demonstrating the configuration's artrecognized suitability, it would have been obvious to one of ordinary skill to form an additional recess within Nakamura's wall to achieve the predictable result of controlling the direction and quantity of material passing therethrough.

Claim 4: A gate valve (22), i.e., a plate, covers the recess formed in Nakamura's wall (6, 17-23).

Claim 8: This claim is drawn to the intended use of the apparatus, and it has been held that a recitation concerning the manner in which a claimed apparatus is to be employed does not differentiate the apparatus from prior art satisfying the claimed structural limitations (Ex parte Masham, 2 USPQ2d 1647). Nakamura's second pumping unit is capable of evacuating the second volume to a pressure lower than 10° Torr.

Claim 11: Nakamura states that it is well-known in the art to use electron beam guns in addition to or in place of Knudsen cells (1, 64-67). It would have been obvious to one of ordinary skill in the art to employ electron beam guns to achieve the predictable result of executing substrate deposition.

Claim 13: Material sources 7 may be considered "gas injectors" in that they provide or inject gas into the chamber (5, 54-56).

Claims 5 and 6 are rejected under 35 U.S.C. 103(a) as being unpatentable over Nakamura in view of Tomofuji and in further view of Bernard et al., US 2002/0153102.

Nakamura's first and second pump units are not disclosed as comprising primary and secondary pumps. Even so, it is well-known in the art to outfit chamber evacuation units with primary and secondary pumps. For example, Bernard, disclosing an apparatus for conditioning the atmosphere in a vacuum chamber, evacuates the chamber (1) with a pumping system consisting of both a primary (3) and secondary (2) pump [0042]. This pumping arrangement

Application/Control Number: 10/518,119

Art Unit: 1712

proficiently executes rapid variations in chamber pressure as needed and is also capable of pumping a variable atmosphere. Accordingly, it would have been obvious to one of ordinary skill in the art to equip each pumping unit with primary and secondary pumps to achieve the predictable result of rapidly varying the chamber atmosphere as required by the instant stage of processing.

Claim 7 is rejected under 35 U.S.C. 103(a) as being unpatentable over Nakamura in view of Tomofuji and Bernard as applied to claim 5 and in further view of Colombo. US 5.951.767.

Nakamura does not teach liquid nitrogen storage panels disposed in the first volume, but does dispose liquid nitrogen shrouds (6) about the material sources. In supplementation, Colombo, disclosing an MBE apparatus, attests that incorporating cryogenic (liquid nitrogen) storage panels within the chamber walls provides an excellent means for temperature regulation (2, 5-10; 2, 60-65; 4, 10-15). Provided with this teaching, it would have been obvious to one of ordinary skill to integrate liquid nitrogen storage panels throughout the entire chamber perimeter to effectively cool the chamber atmosphere.

Claim 9 is rejected under 35 U.S.C. 103(a) as being unpatentable over Nakamura in view of Tomofuji and in further view of Nyberg et al., US 4,654,231.

Nakamura does not explicitly state that a gauge is provided to measure the pressure of the two volumes; the reference does, however, articulate ideal pressure values for each volume, thereby demonstrating a need to quantify the chamber's vacuum condition. Nyberg is cited for the demonstration that it is well-known in the art to, firstly, avail a Bayard-Alpert gauge to assess the pressure condition of a deposition chamber and, secondly, communicate the pressure measurement to a control unit for responsive system adjustment (3, 3-12). It would have been obvious to one of ordinary skill in the art at the time the invention was made to outfit each vacuum region of Nakamura's apparatus with a pressure gauge and to further relay the result to a controller to permit real-time pressure adjustments.

Claim 10 is rejected under 35 U.S.C. 103(a) as being unpatentable over Nakamura in view of Tomofuji and in further view of Demay et al., US 4,813,373.

Nakamura's material sources disposed within the second volume are Knudsen cells which comprise crucibles. The manner of their heating is not disclosed. Nevertheless, as Demay demonstrates, heating evaporation cells via Joule effect is well-known in the art. Specifically, Demay elaborates a deposition system comprising evaporant Application/Control Number: 10/518,119

Art Unit: 1712

crucibles (1, 63ff). The crucibles are heated by Joule effect to evaporate the deposition species; further, this technique heats the cell isothermally and obviates difficulties with condensation (6, 5-15). Provided with this attestation of suitability, it would have been obvious to one of ordinary skill to heat Nakamura's Knudsen cells by Joule effect to achieve the predictable result of evaporating the deposition species.

Claim 12 is rejected under 35 U.S.C. 103(a) as being unpatentable over Nakamura in view of Tomofuji and in further view of Takahashi. US 5.588.999.

Nakamura does not disclose a plasma source. Takahashi remedies this deficiency in teaching an MBE system which provides plasma to a vacuum chamber to facilitate the formation of oxide films or compound semiconductor films (1, 23-31), which is exactly the end pursued by Nakamura (1, 9-15). Accordingly, it would have been obvious to one of ordinary skill to provide plasma to Nakamura's processing chamber to facilitate the formation of oxide semiconductor films.

Lastly, as the applicant has not demonstrated the criticality of situating the plasma source exclusively in the first volume, it is the examiner's position that disposing the plasma source in either volume would beget equivalent results and its placement is therefore arbitrary – one of ordinary skill would recognize that positioning the plasma source within the first volume would sufficiently enable the formation of an oxide film. It should also be noted that Nakamura's first volume possesses a gas injector (7) capable of supplying a plasma gas. Further, it has been held that rearranging the parts of an invention involves only routine skill in the art (In re Japikse, 86 USPQ 70).

THIS ACTION IS MADE FINAL Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a). A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the mailing date of this final action.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Nathan K. Ford whose telephone number is 571-270-1880. The examiner can normally be reached on M-F, 8:30-5:00 EDT. If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Michael Cleveland, Art Unit: 1712

can be reached at 571-272-1418. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

/N. K. F./

Examiner, Art Unit 1712

/Karla Moore/

Primary Examiner, Art Unit 1716